



PATENT

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October 6, 2003
Date

Tamra Miller
Tamra Miller

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/970,100

Confirmation No. : 2699

Applicants : Vishnu K. Agarwal and
Scott G. Meikle

Attorney Docket No.: 500453.04 (29113/US/3)

Filed : October 2, 2001

Customer No. : 27,076

Art Unit : 1762

Examiner : William P. Fletcher III

Title : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR
CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE
SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH
PADS AND MACHINES

AMENDMENT UNDER 37 C.F.R. §1.114

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 7 of this paper.